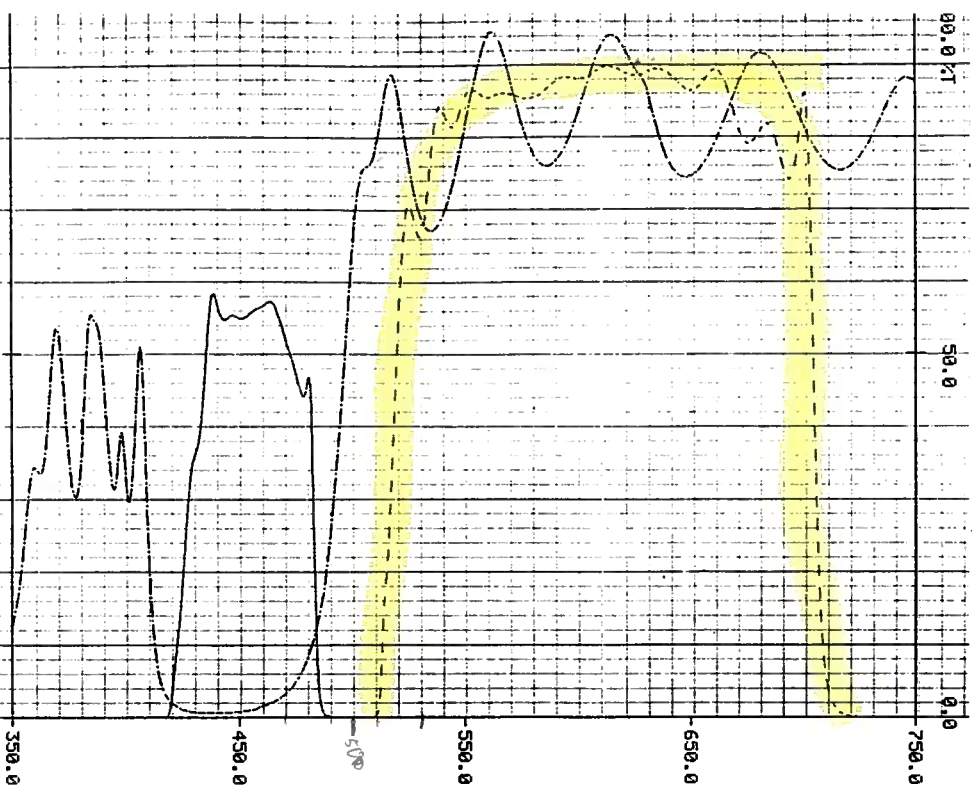


CITATION: 455DF70 (FULL LINE)
 ICHROIC: 505DRLPEXTO2 AT 45° AOI (CHAIN LINE)
 MISSION: 515EFLP (BROKEN LINE)

SPECTRAL CONTROL:

CITATION: 0.8 CWL TO FAR IR X-AXIS: 350-750 nm X-SCALE: 10 nm/div.
 MISSION: X-RAY TO 1.2 x CWL Y-AXIS: 0-100%T

Arrows on excitation and emission filters point in the direction of light path



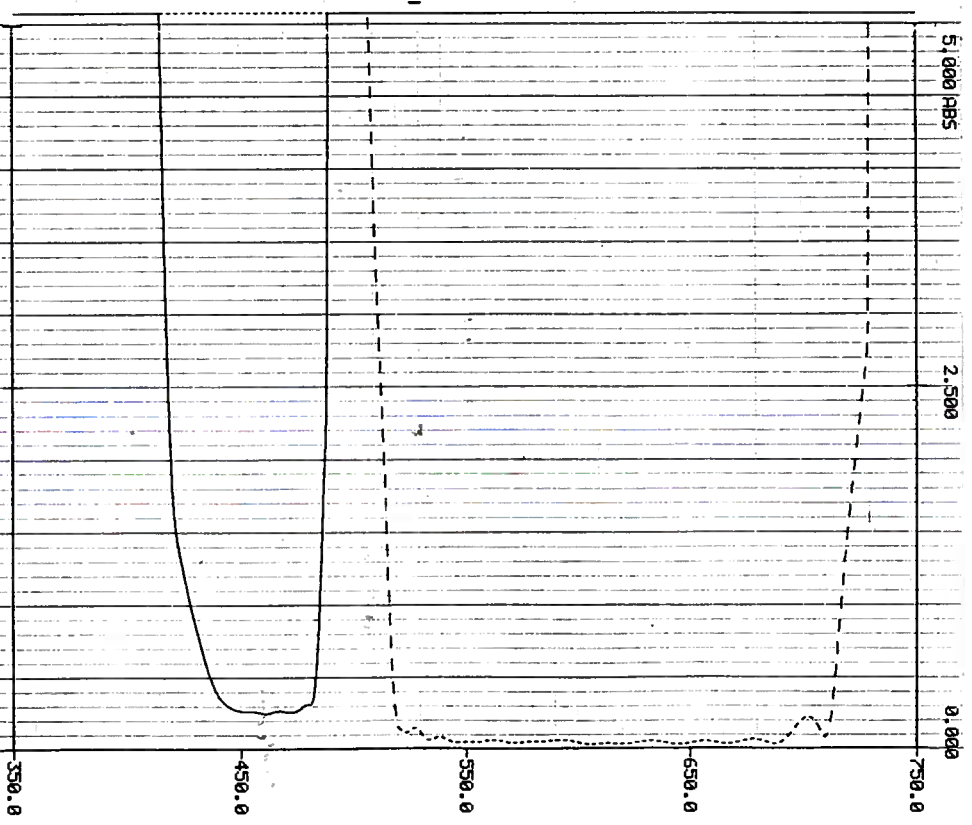
CLEANING OF OPTICAL COMPONENTS
 Hold by edges only. First, remove any foreign particles with a puff of dry air. Wipe gently with a soft, lint-free cloth. A final wipe with a few drops of pure anhydrous alcohol will result in a clean, undamaged component.

EXCITATION: 455DF70 (FULL LINE)
 DICHOIC: 505DRLPEXTO2
 EMISSION: 515EFLP (BROKEN LINE)

SPECTRAL CONTROL:

EXCITATION: 0.8 CWL TO FAR IR X-AXIS: 350-750 nm X-SCALE: 10 nm/div.
 EMISSION: X-RAY TO 1.2 x CWL Y-AXIS: O.D. 0.5

Arrows on excitation and emission filters point in the direction of light path



CLEANING OF OPTICAL COMPONENTS
 Hold by edges only. First, remove any foreign particles with a puff of dry air. Wipe gently with a soft, lint-free cloth. A final wipe with a few drops of pure anhydrous alcohol will result in a clean, undamaged component.